

10/540498

JC09 Rec'd PCT TO 23 JUN 2005 of 1

PTO-1449		Application No. Unknown		Applicant(s) Steven David Benford, et al.	
Information Disclosure Citation In an Application		Docket Number 072819.0181	Group Art Unit Unknown	Filing Date June 23, 2005	

U.S. PATENT DOCUMENTS

/R.R./	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
/R.R./ A	5,504,501	04/02/96	Hauck, et al.	G09G	5/08	07/18/94
/R.R./ B	5,515,079	05/07/96	Hauck	G09G	5/08	11/29/93
/R.R./ C	6,275,214	08/14/01	Hansen	G09G	5/00	07/06/99
D						
E						
F						
G						
H						
I						
J						
K						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
/R.R./ L	WO/52230 A	07/19/00	PCT	G09G	5/00	X	
M							
N							
O							
P							

DOCUMENT (Including Author, Title, Source, and Pertinent Pages)

DATE

/R.R./ Q	Olsen, D.R., et al., "Laser Pointer Interaction," Association for Computing Machinery, Conference on Human Factors in Computing Systems, 2001 Conference Proceedings, Seattle, WA, IEEE, pp. 17-22	03/31-04/05/2001
R		
S		

EXAMINER

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DATE CONSIDERED

01/15/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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PTO-1449

25 2005 Application No.

Applicant(s)

Information Disclosure Citation
In an Application16340,498
Docket Number
072819.0181

Steven David Benford, et al.

Group Art Unit
UnknownFiling Date
06/23/05

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
/R.R.A	5,741,185	04/21/98	Kwan, et al.			
B						
C						
D						
E						
F						
G						
H						
I						
J						
K						
L						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
/R.R.M	JP11039094	02/12/99	Japan			
/R.R.N	JP55001750	01/08/80	Japan			
/R.R.O	WO0031680	06/02/00	PCT			
/R.R.P	DE10042982	03/14/02	Germany			

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
Q		
R		

	DATE CONSIDERED
/Robert Rainey/	01/15/2008

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